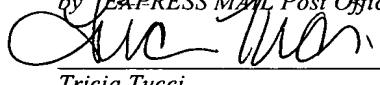


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application. No. : U.S. Filing of International Application PCT/DE2004/002319
Applicants : Heinrich WILD, Ludwig BREHM, Achim HANSEN
Confirm. No. : Unassigned
Filed : Herewith
Title : METHOD FOR PRODUCTION OF A FILM
TC/A.U. : N/A
Examiner : N/A
Docket No. : 1093-154 PCT/US
Dated : April 18, 2006

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: 4/18/06 Label No. EL 722317267 US
I hereby certify that on the date indicated above, I
deposited this paper or fee with the U.S. Postal Service
and that it was addressed for delivery to the Commissioner
for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
by "EXPRESS MAIL Post Office to Addressee" Service.



Tricia Tucci

INFORMATION DISCLOSURE STATEMENT

Sir:

In order to fulfill the requirements of candor and good faith set forth in 37 C.F.R. §1.56, Applicants submit herewith the following Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §1.97 and §1.98.

FOREIGN PATENT DOCUMENTS

<u>COUNTRY</u>	<u>PUBLICATION NO.</u>	<u>PUBLICATION DATE</u>
WIPO	WO 02/25750 A1	March 28, 2002
Germany	DE 100 33 112 A1	January 24, 2002
WIPO	WO 02/47183 A1	June 13, 2002
WIPO	WO 02/070271 A2*	September 12, 2002
Europe	EP 1 041 620 A2*	October 4, 2000

WIPO	WO 99/49525*	September 30, 1999
Europe	EP 1 326 289 A2	July 9, 2003
Germany	DE 196 33 675 A1	February 26, 1998

OTHER REFERENCES

Fujita, et al., “Flexible Organic Field-Effect Transistors Fabricated by the Electrode-Peeling Transfer with an Assist of Self-Assembled Monolayer”, Applied Physics Letters, Volume 82, Number 24, pp. 4373-4375 (June 16, 2003).*

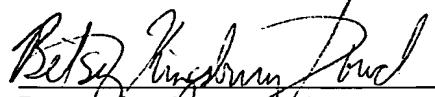
The above-referenced documents are listed on Form PTO-1449. The documents marked with an asterisk were cited in the International Search Report (ISR) submitted herewith. Foreign patent documents EP 1 326 289 A2 and DE 196 33 675 were cited in the prosecution of the corresponding Germany application. We have enclosed copies of all patent documents not cited in the ISR along with English abstracts corresponding to any non-English publications to facilitate reference to them.

Applicants respectfully submit that the requirements of candor and good faith set forth in 37 C.F.R. §1.56 have been fulfilled, having submitted all known references in compliance with 37 C.F.R. § 1.97 and § 1.98. Applicants believe that no fee is due at this time. If it is determined that a fee is due, please charge our Deposit Account No. 08-2461.

10/576098
IAP15 Rec'd PCT/PTO 17 APR 2006

In view of the present submission, it is believed that the above-referenced application is, in all respects, complete and in condition for examination and favorable consideration. If the Examiner has any questions or comments relating to the present application, he or she is respectfully invited to contact Applicants' attorney at the telephone number set forth below.

Respectfully submitted,



Betsy Kingsbury Dowd
Registration No. 52,830
Attorney for Applicant(s)

HOFFMANN & BARON, LLP
6900 Jericho Turnpike
Syosset, New York 11791
(516) 822-3550
BKD:tt

219989_1

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE (Rev. 2-32) PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. 1093-154 PCT/US	SERIAL NO. 10/576098 Unassigned
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			APPLICANT Wild, et al.	CONFIRMATION NO. Unassigned
(Use several sheets if necessary)			FILING DATE Herewith	GROUP Unassigned

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
						YES	NO
	WO 02/25750 A1	3/28/02	WIPO				
	DE 100 33 112 A1	1/24/02	Germany				
	WO 02/47183 A1	6/13/02	WIPO				
	WO 02/070271 A2*	9/12/02	WIPO				
	EP 1 041 620 A2*	10/4/00	Europe				
	WO 99/49525*	9/30/99	WIPO				
	EP 1 326 289 A2	7/9/03	Europe				
	DE 196 33 675 A1	2/26/98	Germany				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		Fujita, et al., "Flexible Organic Field-Effect Transistors Fabricated by the Electrode-Peeling Transfer with an Assist of Self-Assembled Monolayer", Applied Physics Letters, Volume 82, Number 24, pp. 4373-4375 (June 16, 2003).*
--	--	---

U.S. PATENT PUBLICATIONS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication with applicant.